

Notice of References Cited			Application No. 09-788,629		Applicant(s) Usuc et. al	
			Examiner George Gaudreau		Group Art Unit 1763	Page 1 of 1

U.S. PATENT DOCUMENTS					
*	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,627,640	5-97	Chang et al	356	31C
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N	58-144,476	8-931	Japan	Watanabe et al		
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NON-PATENT DOCUMENTS	
*	DOCUMENT (Including Author, Title, Source, and Pertinent Pages) DATE
U	"Use of a Light Emitting Diode As A Current Sensor For Electrostatic Double Probes"; Rev. of Sci. Instru.; (2-87);
W	Vol 58, no. 2, pp. 315-317; Tondys et. al
W	"A Plasmascope Using Light Emitting Diodes"; Rev. of Sci. Instru.; (1-74); Vol 45, no. 1; pp 57-59; Ejima et. al
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* A copy of this reference is not being furnished with this Office action.
(See Manual of Patent Examining Procedure, Section 707.05(a).)